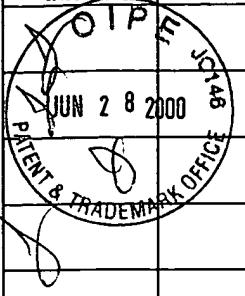


EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form PTO-1449 (Reproduced) INFORMATION DISCLOSURE CITATION IN AN APPLICATION <i>(Use several sheets if necessary)</i>				Docket Number (Optional) AD6430 US CIP		Application Number 09/494,107	
				Applicant I-HWA LEE ET AL.		Filing Date JANUARY 28, 2000	
				Group Art Unit 1711			
				U. S. PATENT DOCUMENTS			
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
	3,645,992	2-29-72	Elston	260	80.78	/	
	4,076,698	2-28-78	Anderson et al.	526	348.6	/	
	5,198,401	3-30-93	Turner et al.	502	155	/	
	5,405,972	4-11-95	DeChellis et al.	526	68	/	
FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION YES <input checked="" type="checkbox"/> NO <input type="checkbox"/>	
	EP0266994	5-11-88	EPO	260	80.78	/	
OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>							
EXAMINER	<i>Jeffrey M. K.</i>		DATE CONSIDERED		1-01		
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